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10784979 - GALL 2166

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| Application Number     |  | 10784979           |
| Filing Date            |  | 2004-25-02         |
| First Named Inventor   |  | David YACH, et al. |
| Art Unit               |  | 2166               |
| Examiner Name          |  | LIN, Shew Fen      |
| Attorney Docket Number |  | P1645US00          |

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